

41

00862.022199.

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Keiji EMOTO

Application No.: 09/833,766

Filed: April 13, 2001

For: PIPE STRUCTURE, ALIGNMENT APPARATUS,
ELECTRON BEAM LITHOGRAPHY APPARATUS,
EXPOSURE APPARATUS, EXPOSURE APPARATUS
MAINTENANCE METHOD, SEMICONDUCTOR DEVICE
MANUFACTURING METHOD, AND SEMICONDUCTOR
MANUFACTURING FACTORY

Examiner: P. L. Rodriguez

Group Art Unit: 2125

Confirmation No.: 4154

RECEIVED**SEP 22 2004****Technology Center 2100**

September 20, 2004

Mail Stop Amendment

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

Sir:

Transmitted herewith is an Amendment in the above-identified application.

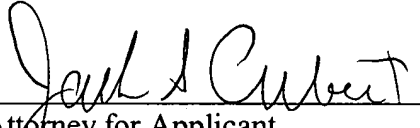
☒ No additional fee is required.

The fee has been calculated as shown below:

CLAIMS AS AMENDED						
	CLAIMS REMAINING AFTER AMENDMENT		HIGHEST NO. PREVIOUSLY PAID FOR	PRESENT EXTRA	RATE	ADDITIONAL FEE
TOTAL CLAIMS	10	MINUS	27	= 0	x \$9 \$18	\$0.00
INDEP. CLAIMS	2	MINUS	11	= 0	x \$43 \$86	\$0.00
Fee for Multiple Dependent claims \$145/\$290						—
TOTAL ADDITIONAL FEE FOR THIS AMENDMENT						\$0.00

- ☐ °Verified Statement claiming small entity status is enclosed, if not filed previously.
- ☐ A check in the amount of \$_____ is enclosed including the additional claims fee.
- ☐ Charge \$____ to Deposit Account No. 06-1205. A duplicate of this sheet is enclosed.
- ☒ Any prior general authorization to charge an issue fee under 37 CFR 1.18 to Deposit Account No. 06-1205 is hereby revoked. The Commissioner is hereby authorized to charge any additional fees under 37 CFR 1.16 and 1.17 which may be required during the entire pendency of this application, or to credit any overpayment, to Deposit Account No. 06-1205. A duplicate of this paper is enclosed.
- ☐ A check in the amount of \$_____ to cover the fee for a two month extension is enclosed.
- ☐ A check in the amount of \$_____ to cover the Information Disclosure Statement fee is enclosed.
- ☒ Applicant's attorney, Steven E. Warner, may be reached in our Washington, D.C. office by telephone at (202) 530-1010. All correspondence should be directed to our address given below.

Respectfully submitted,



Attorney for Applicant
Jack S. Cubert
Registration No. 24,245

FITZPATRICK, CELLA, HARPER & SCINTO
30 Rockefeller Plaza
New York, New York 10112-3800
Facsimile: (212) 218-2200
SEW/JSC/dc

DC_MAIN 178486v1

00862.022199



PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)	
Keiji EMOTO)	: Examiner: P. L. Rodriguez
Application No.: 09/833,766)	: Group Art Unit: 2125
Filed: April 13, 2001)	: Confirmation No.: 4154
)	:
For: PIPE STRUCTURE, ALIGNMENT APPARATUS,)	: September 21, 2004
ELECTRON BEAM LITHOGRAPHY)	:
APPARATUS, EXPOSURE APPARATUS,)	:
EXPOSURE APPARATUS MAINTENANCE)	:
METHOD, SEMICONDUCTOR DEVICE)	:
MANUFACTURING METHOD, AND SEMI-)	:
CONDUCTOR MANUFACTURING FACTORY)	:

RECEIVED

SEP 22 2004

Technology Center 2100

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

AMENDMENT

Sir:

In response to the Office Action dated June 21, 2004, please amend the above identified application as follows: